

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/620,688	<b>Applicant(s)/Patent under Reexamination</b> HANAMOTO, TAKASHI
	<b>Examiner</b> Beniyam Menberu	<b>Art Unit</b> 2625

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner